



Serial No. 09/832,330
SEC.850
Amendment dated October 21, 2003

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent application of :
Young-Joon CHO et al. : Group Art Unit 1746
Serial No. 09/832,330 : Examiner Alexander Markoff
Filed April 11, 2001 :

SEMICONDUCTOR WAFER CLEANING APPARATUS AND METHOD OF
USING THE SAME

AMENDMENT

U.S. Patent and Trademark Office
2011 South Clark Place
Customer Window, **Mail Stop Fee Amendment**
Crystal Plaza Two, Lobby, Room 1B03
Arlington, VA 22202

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Sir:

In response to the Office action of July 2, 2003, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 4 of this paper.

Amendments to the Drawings begin on page 5 of this paper and include an attached replacement sheet.

Remarks/Arguments begin on page 6 of this paper.